Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

- 1. (Original) A semiconductor device for emitting light when a voltage is applied comprising
- a first semiconductor region (3) whose conductivity is based on charge carriers of a first conductivity type,
- a second semiconductor region (5) whose conductivity is based on the charge carriers of a second semiconductor type, which have a charge opposite to the charge carriers of the first conductivity type, and
- an active semiconductor region (7A 7C) which is arranged between the first semiconductor region (3) and the second semiconductor region (5) and in which quantum structures (13) of a semiconductor material with a direct band gap are embedded.
- 2. (Original). A semiconductor device as set forth in claim 1 wherein the first semiconductor region (3), the second semiconductor region (5) and the active semiconductor region (7A 7C) each include $Al_xGa_{1-x}P$ with $0 \le x \le 1$ and the quantum structures (13) are made from a III-V semiconductor material having a lattice constant which is greater than that of GaP.
- 3. (Original) A semiconductor device as set forth in claim 2 wherein the III-V semiconductor material includes InP.
- 4. (Currently Amended) A semiconductor device as set forth in claim 1, $\frac{1}{2}$ or claim 3 wherein the semiconductor regions are embodied in the form of semiconductor layers (3, 5, 7A 7C) of a layer stack.

- 5. (Currently Amended) A semiconductor device as set forth in ene of claims 1 through 4 claim 1 wherein the quantum structures (13) are of a lateral extent which on average is less than about 50 nm.
- 6. (Original) A semiconductor device as set forth in claim 5 wherein the average lateral extent of the quantum structures (13) is in the range of between 10 and 30 nm.
- 7. (Currently Amended) A semiconductor device as set forth in claim 3, and one of claims 4 through 6 wherein the InP coverage is at least 0.5 ML.
- 8. (Original) A semiconductor device as set forth in claim 7 characterised in that the active semiconductor region (7A 7C) includes a plurality of sub-regions which have different InP coverages.
- 9. (Currently Amended) A light emitting diode comprising a semiconductor device as set forth in one of claims 1 through 8 claim 1.
- 10. (Currently Amended) A superluminescent diode comprising a semiconductor device as set forth in one of claims 1 through 8 claim 1.
- 11. (Currently Amended) A laser diode comprising a semiconductor device as set forth in one of claims 1 through 8 claim 1.